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PATENT
Attorney Docket No. 29936/39455

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicants: |) | I hereby certify that this paper is being |
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| Dong Ho Lee <i>et al.</i> |) | Service as first class mail, postage |
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| Serial No. 10/613,616 |) | Commissioner for Patents, P.O. Box |
| |) | 1450, Alexandria, VA 22313-1450 on |
| Filed: July 3, 2003 |) | this date: |
| |) | |
| For: Method Of Manufacturing A |) | December 27, 2004 |
| Semiconductor Wafer |) | |
| |) | |
| Group Art Unit: 2813 |) | <u>Andrew M. Lawrence</u> |
| |) | Andrew M. Lawrence, Reg. No. 46,130 |
| Examiner: Chandra P. Chaudhari |) | Attorney for Applicants |

PETITION UNDER 37 C.F.R. § 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants, by their attorney, petition for a one-month extension of time to file a response to the official action dated August 25, 2004.

Submitted herewith is a check covering the patent application processing fee of \$120.00.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

December 27, 2004

Andrew M. Lawrence

Andrew M. Lawrence, Reg. No. 46,130
Attorney for Applicants
6300 Sears Tower
233 S. Wacker Drive
Chicago, Illinois 60606-6357
(312) 474-6300

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